



IPW

Reference to:  
Application No.: 10/723,046  
Filing date: 11/26/2003  
Art unit: 2811  
Applicants: Hui Peng  
Title: Texture on Substrate and a Method for Minimizing Effects of Lattice Mismatch  
Examiner/Art Unit Shouxiang Hu/2811

Fremont, CA, Feb. 17 , 2005

**AMENDMENT A**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This letter responses to the Office Action Summary dated Nov. 26, 2004 and mailed to applicant on 12/01/2004. Please amend the above patent application as the following.

**TITLE:** Amendment to the title of the above patent application is on page 2 of this amendment.

**SPECIFICATION:** There is no amendment to the specification.

**CLAIMS:** Amendment to the claims of the above patent application begin on page 3 of this amendment.

**DRAWINGS:** There is no amendment to the drawings.

**REMARKS:** Remarks begin on page 5 of this amendment.



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